

Notice of References Cited	Application/Control No. 10/565,339		Applicant(s)/Patent Under Reexamination FUJISAWA ET AL.	
	Examiner Tina M. Wong		Art Unit 2874	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,813,412	11-2004	Lin, Chuang-Chia	385/19
*	B	US-6,169,826	01-2001	Nishiyama et al.	385/22
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	K	US-			
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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